Docket Number (Optional) Application Number 56231-417 (MKS-131) 10/669,065 ON-ORTATION DISCLOSURE CITATION Applicant(s) Ali Shajii et al. several sheets if necessary) Filing Date Group Art Unit MAY 0 3 2004 September 23, 2003 2855 **U.S. PATENT DOCUMENTS** EXAMINER FILING DATE DOCUMENT NUMBER DATE NAME CLASS SUBCLASS INITIAL IF APPROPRIATE FOREIGN PATENT DOCUMENTS Translation CLASS REF DOCUMENT NUMBER DATE COUNTRY SUBCLASS YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Zhiyao Huang et al., "Application of Electrical Capicitance Tomography to the Void Fraction Measurement of Two-Phase Flow", IEEE Transactions on Instrumentation and Measurement, Vol. 52, No. 1, February 2003, pp. 7-12. Kjetil Ullaland, "The Design of a VLSI Mixed Analogue and Digital Modular ASIC Processor for Capacitance Tomography", October 1994, University of Bergen, Bergen, Norway, pp. 4.1 - 4.6. DATE CONSIDERED EXAMINE EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.